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CONFIRMATION NO. 6475

<b>SERIAL NUMBER</b> 10/666,912	<b>FILING OR 371(c) DATE</b> 09/19/2003 <b>RULE</b>	<b>CLASS</b> 427	<b>GROUP ART UNIT</b> 1734	<b>ATTORNEY DOCKET NO.</b> SIPXP054C1
<b>APPLICANTS</b> Jeanne E. Haubrich, San Jose, CA; Yi-Shung Chaug, Los Altos, CA; Zarnge-Arh George Wu, San Jose, CA; Rong-Chang Liang, Cupertino, CA;				
<b>** CONTINUING DATA *****</b> This application is a CIP of 10/422,557 04/23/2003 which claims benefit of 60/375,902 04/24/2002				
<b>** FOREIGN APPLICATIONS *****</b>				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 12/12/2003				
<b>** SMALL ENTITY **</b>				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35.U.S.C. 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Chan Shing So</i> <i>SPC</i> Examiner's Signature Initials	<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWING</b> 16	<b>TOTAL CLAIMS</b> 66	<b>INDEPENDENT CLAIMS</b> 4
<b>ADDRESS</b> 46006				
<b>TITLE</b> Process for forming a patterned thin film structure on a substrate				
<b>FILING FEE RECEIVED</b> 907	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			
<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit				